

THW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of:

Ryan Chia-Jen Chen

Group Art Unit: 2823

Serial No.: 10/788,754

Examiner: Brewster, William M.

Filed: Feb. 27, 2004

In Response to Office Action  
Dated: Dec. 3, 2004

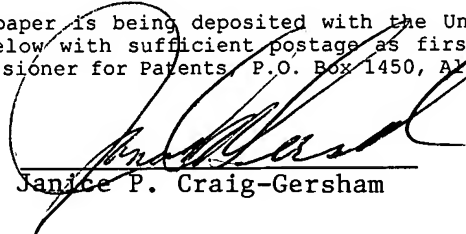
For: Offset Spacer Manufacturing For Critical  
Dimension Precision

Attorney Docket No.: 67,200-1217 (2003-0729)

Certificate of Mailing

I hereby certify that this paper is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: 12-30-2004

  
Janice P. Craig-Gersham

RESPONSE TO OFFICE ACTION

Commissioner for Patents  
Alexandria, VA 22313-1450

Dear Sir:

In response to a restriction requirement imposed by the Examiner mailed Dec. 3, 2004, the Applicants hereby elect with traverse the prosecution of Group I, method claims 1-21.